



Docket No.: M4065.0165/P165
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Garry A. Mercaldi et al.

Application No.: 09/285,773

Art Unit: 1765

Filed: April 5, 1999

Examiner: L. Umez-Eronini

For: METHOD FOR ETCHING DOPED
POLYSILICON WITH HIGH
SELECTIVITY TO UNDOPE
POLYSILICON

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JAN 21 2004
TC 1700

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated October 24, 2003 (Paper No. 33), please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.